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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re the Application of: TAKESHITA, Mitsunori, et al.

ATTN: PCT BRANCH

Serial No.: 10/593,282

Group Art Unit: Not Yet Assigned

Filed: September 18, 2006

P.T.O. Confirmation No.: 8499

For:

SUBSTRATE PROCESSING APPARATUS AND MANUFACTURING METHOD

FOR A SEMICONDUCTOR DEVICE

## SUBMISSION OF DECLARATION AND POWER OF ATTORNEY

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

April 22, 2008

Dear Sir:

Enclosed herewith for filing is the executed Declaration and Power of Attorney for the above-identified patent application.

Please note that the surcharge fee of \$130.00 for filing the late Declaration was paid at the initial filing. The fees enclosed at initial filing on September 18, 2006 were \$1,030.00 (\$300.00 for basic filing fees, \$400.00 for the search fee, \$200.00 for the examination fee, and \$130.00 for filing the late Declaration). In the event that any additional fees are due with this paper, please charge Deposit Account No. 01-2340.

In the event that this response is not timely filed, the applicants hereby petition for an appropriate extension of time. The fees for any such extension may be charged to our Deposit Account No. 01-2340.

Respectfully submitted,

KRATZ, QUINTOS & HANSON, LLP

Mel R. Quintos Attorney for Applicants Reg. No. 31,898

MRQ/rmp

Atty. Docket No. **060711** Suite 400 1420 K Street, N.W. Washington, D.C. 20005 (202) 659-2930

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PATENT & TRADEMARK OFFICE

Enclosures: Declaration and Power of Attorney